

UNIVERSITY OF NIŠ

Course Unit Descriptor	aculty	Faculty of Mechanical Engineering			
GENERAL INFORMATION					
Study program		Mechatronics and Control			
Study Module (if applicable)	-	-			
Course title	Microme	Micromechatronics			
Level of study	Bache	elor 🛛 Master's 🗌 Doctoral			
Type of course	⊠Obliga	Obligatory Elective			
Semester	Autur	Autumn Spring			
Year of study	I				
Number of ECTS allocated	7				
Name of lecturer/lecturers	Nenad D	Nenad D. Pavlović, Miloš Milošević			
Teaching mode	Labor	Lectures Group tutorials Individual tutorials Laboratory work Project work Seminar Distance learning Blended learning Other			
PURPOSE AND OVERVIEW (max. 5 sentences)					
The purpose of this course is to gain some basic knowledge from the field of micromachining technologies, examples of microstructures application and physical effects for transforming signals at microsensors, that is, for transformation of energy in micro actuators. Students should gain the ability for suitable selection and calculation of microstructures and microsensors, for recognizing the transformation of energy in micro actuators, as well as the application of micromachining technologies for the realization of microstructures and devices.					
SYLLABUS (brief outline and summary of topics, max. 10 sentences)					
 Physical basis of micromachining (characteristics of materials in micromachining, physical effects for signals transforming). Fabrication and manufacture (silicon processes: lithographic processes, manufacturing techniques of thin layers, etching processes, technology processes of laser processing in micromachinig, LIGA and SLIGA processes, bonding and assembly processes). 					

• Applications: basic structures and elements of bulk micromachining; microsensors and transducers (sensors of

pressure, acceleration and vibration, force, flow velocity and flow, thermal radiation, for gas analysis, miniature quartz crystal resonators as sensors with frequency modulated outputs); mikroactuators (microswitches, modulators of light and elements of optical displays, microfluidic devices, elements for micropositioning, micro-motors, miniature grippers for microassembly, medical applications, mini- and micromechanisms.

 Introduction to modeling of multiphysical effects on which the functioning of the micromechatronical systems is based.

LANGUAGE OF INSTRUCTION					
Serbian (complete course)		(complete course) 🛛 🗌 Other	(complete course)		
Serbian with English mentoring Serbian with German mentoring					
ASSESSMENT METHODS AND CRITERIA					
Pre exam duties	Points	Final exam	points		
Activity during lectures	10	Written examination			
lomework 10		Oral examination (3 Teaching Colloquia)	Max. 30+20+20		
aboratory work 10		OVERALL SUM	100		
*Final examination mark is formed in accordance with the Institutional documents					